



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of )  
YANG, Nian, et al. ) Examiner: PHAM,  
Long  
Serial No. 10/758,148 ) Group Ad Unit: 2814  
Filing Date: January 14, 2004 ) Confirmation No.: 4639  
)  
For: EFFICIENT USE OF )  
WAFER AREA WITH )  
DEVICE UNDER THE PAD )  
APPROACH )

AMENDMENT AND RESPONSE TO OFFICE ACTION

Hon. Assistant Commissioner for Patents  
P.O. Box No. 1450  
Alexandria, Virginia 22313-1450

Dear Sir/Madam,

In response to the Office Action mailed August 11th, 2006, Applicant respectfully requests reconsideration of the above referenced patent application. Please amend the above identified application as follows and consider the following remarks for allowance of the above identified patent application.